



CUSTOMER NUMBER 25268

**INFORMATION DISCLOSURE STATEMENT LISTING SHEET**

**Information Cited By Applicant(s) That May Be Material To  
The Prosecution Of The Subject Application**

Applicants: Crossman-Bosworth et al. Attorney Docket No. UNIV0200  
Serial No.: 10/763,896 Group Art Unit: 2131  
Filed: January 23, 2004 Examiner:  
Title: OPTICAL BEAM SCANNING SYSTEM FOR COMPACT IMAGE DISPLAY  
OR IMAGE ACQUISITION

**U.S. PATENT DOCUMENTS**

*Examiner Initial	ID	Document No.	Date	Name	Class	Sub-Class
JH	US1	2002/0064341	05/2002	Fauver et al.	385	25
JH	US2	2001/0055462	12/2001	Seibel	385	147
JH	US3	4,118,270	10/03/1978	Pan et al.	156	659
JH	US4	4,265,699	05/05/1981	Ladany	156	657
JH	US5	4,410,235	10/18/1983	Klement et al.	350	96.18
JH	US6	4,454,547	06/12/1984	Yip et al.	358	293
JH	US7	4,743,283	05/1988	Borsuk	65	387
JH	US8	4,768,513	09/1988	Suzuki	---	---
JH	US9	4,804,395	02/1989	Clark et al.	65	387
JH	US10	4,824,195	04/25/1989	Khoe	350	96.18
JH	US11	5,037,174	08/06/1991	Thompson	385	33
JH	US12	5,074,642	12/24/1991	Hicks	385	116
JH	US13	5,172,685	12/1992	Nudelman	---	---
JH	US14	5,231,286	07/27/1993	Kajimura et al.	250	234
JH	US15	5,247,174	09/21/1993	Berman	250	235
JH	US16	5,272,330	12/21/1993	Betzig et al.	250	216
JH	US17	5,286,970	02/15/1994	Betzig et al.	250	227.26
JH	US18	5,394,500	02/28/1995	Marchman	385	123
JH	US19	5,425,123	6/13/1995	Hicks	385	117
JH	US20	5,459,803	10/17/1995	Yamane et al.	385	33
JH	US21	5,480,046	01/02/1996	Filas et al.	216	7
JH	US22	5,563,969	10/08/1996	Honmou	385	35
JH	US23	5,570,441	10/29/1996	Filas et al.	385	43
JH	US24	5,627,922	05/1997	Kopelman et al.	385	12
JH	US25	5,703,979	12/30/1997	Filas et al.	385	43
JH	US26	5,715,337	02/03/1998	Spitzer et al.	385	4

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JH	US27	5,727,098	03/10/1998	Jacobson	385	31
JH	US28	5,894,122	04/1999	Tomita	250	234
JH	US29	5,939,709	08/1999	Ghislain et al.	250	216
JH	US30	6,046,720	04/04/2000	Melville et al.	345	108
JH	US31	6,091,067	07/18/2000	Drobot et al.	250	234
JH	US32	6,097,528	08/01/2000	Lebby et al.	359	251
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JH	US34	6,211,094	04/03/2001	Adair et al.	348	76
JH	US35	6,294,775	09/25/2001	Seibel et al.	250	208.1
JH	US36	6,327,493	12/04/2001	Ozawa et al.	600	476
JH	US37	6,441,359	08/27/2002	Cozier et al.	250	216
JH	US38	6,563,105	05/13/2003	Seibel et al.	250	208.1

### FOREIGN PATENT DOCUMENTS

<u>*Examiner</u> <u>Initial</u>	<u>ID</u>	<u>Document No.</u>	<u>Publication</u> <u>Date</u>	<u>Country</u>	<u>Class</u>	<u>Sub-Class</u>	<u>Translation?</u>
JH	F1	EP 1 142 529 A1	10.10.2001	Europe	A61B1	00	
JH	F2	2001174744A2	29.06.2001	Japan	G02B 26	10	No
JH	F3	GB 2340332A	28.01.1999	UK	G02B21	00	
		Abstract Only					

### OTHER INFORMATION

<u>*Examiner</u> <u>Initial</u>	<u>Document</u> <u>No.</u>	<u>Document Information</u>
JH	O1	Barnard, Chris W. and John W. Y. Lit. April 20, 1993. Mode Transforming Properties of Tapered Single-mode Fiber Microlens. <i>Appl. Opt.</i> 30:15: 1958-1962.
JH	O2	Barnard, Chris W. and John W. Y. Lit. May 20, 1991. Single-mode Fiber Microlens with Controllable Spot Size. <i>Appl. Opt.</i> 30:15:1958-1962.
JH	O3	Borreman, A. et al. 2002. "Fabrication of Polymeric Multimode Waveguides and Devices in SU-8 Photoresist Using Selective Polymerization." <i>Proceedings Symposium IEEE/LEOS Benelux Chapter, Amsterdam</i> : pp.83-86.
JH	O4	Dickensheets, D. and G.S. Kino. 1994. "A Scanned Optical Fiber Confocal Microscope." <i>Three-Dimensional Microscopy</i> : 2184:39-47..
JH	O5	Dickensheets, D.L. and G.S. Kino. 5/15/1996. "Micromachined scanning confocal optical microscope." <i>Optics Letters</i> :21:10:764-766.
JH	O6	Lee, Kyung S. and Frank S. Barnes. October 1, 1985. Microlenses on the End of Single-mode Optical Fibers for Laser Applications. <i>Appl. Opt.</i> 24:19: 3134-3139.

### OTHER INFORMATION

<u>*Examiner</u> <u>Initial</u>	<u>Document</u> <u>No.</u>	<u>Document Information</u>
<u>JH</u>	O7	MicroChem. 2001. "SU-8 Resists." 1pg. Available <a href="http://www.microchem.com/products/su_eight.htm">http://www.microchem.com/products/su_eight.htm</a> .
<u>JH</u>	O8	Micro-Chem. Rev. 2/2002. "NANO™ SU-8 2000 Negative Tone Photoresist Formulations 2002-2025." 4pp.
<u>JH</u>	O9	"Optical MEMS 2000 Invited Speakers: Advance Program." 2000. Sponsored by IEEE Lasers and Electro-Optics Society. 16pp. Available: <a href="http://www.ieee.org/organizations/society/leos/LEOSCONF/MEMS/omspeak.html">http://www.ieee.org/organizations/society/leos/LEOSCONF/MEMS/omspeak.html</a> .
<u>JH</u>	O10	Russo, Vera et al. October 1, 1984. Lens-ended Fibers for Medical Applications: A New Fabrication Technique. <i>Appl. Opt.</i> 23:19:3277-3283.
<u>JH</u>	O11	Wang, Wei-Chih et al. 2003. "Deep Reactive Ion Etching of Silicon Using An Aluminum Etching Mask." <i>Proceedings of SPIE</i> . 4876:633-640.
<u>JH</u>	O12	Yamada, Jun-Ichi et al. October 1980. Characteristics of a Hemispherical Microlens for Coupling Between a Semiconductor Laser and Single-Mode Fiber. <i>IEEE J. Quant. Electron.</i> QE-16:10:1067-1072.

  
Examiner's Signature

11-23-04  
Date

\*Examiner: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

RMA:klp  
6/24/04